

1	IS&R	L8	898	(310/348,352,353).CCLS	USPAT	2007/10/3 0 08:37	
2	IS&R	L9	181	(310/348,352,353).CCLS	US- PGPUB	2007/10/3 0 08:37	
3	BRS	L10	1	mems and piezoelectric and first and second and third and electrode and substrate and movable and tunable adj2 gap	US- PGPUB	2007/10/3 0 08:38	

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	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
6	IS&R	L13	198	(310/349).CCLS.	US- PGPUB ; USPAT ; USOCR ; FPRS; EPO; JPO; DERWE NT; IBM_T DB	2007/10/3 0 08:44	
7	BRS	L14	4076	111 or 112 or 113	US- PGPUB ; USPAT ; USOCR ; FPRS; EPO; JPO; DERWE NT; IBM_T DB	2007/10/3 0 08:44	
8	BRS	L15	142	114 and mems	US- PGPUB ; USPAT ; USOCR ; FPRS; EPO; JPO; DERWE NT; IBM_T DB	2007/10/3 0 08:44	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
9	BRS	L16	1	mems and piezoelectric same ((first and second) or (top and bottom) or (upper or lower)) adj2 electrode\$1 and (third or additional or another or other) adj2 electrode and substrate and movable and tunable adj2 gap	US- PGPUB	2007/10/3 0 08:51	
10	BRS	L17	2	mems and piezoelectric same ((first and second) or (top and bottom) or (upper or lower)) adj2 electrode\$1 and (third or additional or another or other) adj2 electrode and substrate and movable and tunable adj2 gap	US- PGPUB ; USPAT ; USOCR ; FPRS; EPO; JPO; DERWE NT; IBM_T DB	2007/10/3 0 08:51	